

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Patent Application**

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Applicants(s): Bedell et al.  
Case: YOR920030340US1  
Serial No.: 10/685,636  
Filing Date: October 15, 2003  
10 Group: 2811  
Examiner: H.K. Vu  
  
Title: Techniques for Layer Transfer Processing

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**REPLY BRIEF**

20 Mail Stop Appeal Brief – Patents  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

25 Sir:

Appellants hereby reply to the Examiner's Answer, mailed January 15,  
2008 (referred to hereinafter as "the Examiner's Answer"), in an Appeal of the final  
30 rejection of claims 1-11 in the above-identified patent application.

**REAL PARTY IN INTEREST**

A statement identifying the real party in interest is contained in  
Appellants' Appeal Brief.

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**RELATED APPEALS AND INTERFERENCES**

A statement identifying related appeals is contained in Appellants' Appeal  
Brief.

STATUS OF CLAIMS

Claims 12-48 were withdrawn from consideration in response to a previous restriction requirement. Claims 1-11 are presently pending in the above-identified patent application. Claims 1-8 and 10-11 are rejected under 35 U.S.C. §102(b)  
5 as being anticipated by Sakaguchi et al. (U.S. Patent No. 6,306,729) and claim 9 is rejected under 35 U.S.C. §103(a) as being unpatentable over Sakaguchi et al. Claims 1 and 6 are being appealed.

STATUS OF AMENDMENTS

10 A statement identifying the status of the amendments is contained in Appellants' Appeal Brief.

SUMMARY OF CLAIMED SUBJECT MATTER

A Summary of the Invention is contained in Appellants' Appeal Brief.  
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STATEMENT OF GROUNDS OF REJECTION TO BE REVIEWED ON APPEAL

Claims 1 and 6 are rejected under 35 U.S.C. §102(b) as being anticipated by Sakaguchi et al.

20 CLAIMS APPEALED

A copy of the appealed claims is contained in an Appendix of Appellants' Appeal Brief.

ARGUMENT

25 Response to Examiner's Answer

The Examiner asserts that the features upon which Applicant relies (i.e, the benefit is that well controlled tunability of the process is accomplished by varying the amount, i.e., dose and the position, i.e., depth of the implanted ions) are not recited in the rejected claims.

30

Appellants note that the cited feature is a *characteristic of the “implanted species,”* that “implanted species” is recited in the claims, and that the cited feature is therefore an *inherent feature of the claims*.

The Examiner further asserts that Appellants’ argument that implantation  
5 infers that the species is positioned at certain locations within the substrate (e.g., the species has a Gaussian distribution) and doping does not provide for positioning a species at certain locations within the doped region is not convincing because the claims are device claims, the limitation is met by the dopant species being present, not the method (implant or deposition) of placing the species. The Examiner asserts that the features  
10 upon which Applicants rely (i.e, positioned at certain locations within the substrate) are not recited in the rejected claim(s).

Contrary to the Examiner’s assertion, since the “implanted species” limitation clearly defines a characteristic of the structure itself, the “implanted species” limitation is a valid limitation for a structure/device claim. Furthermore, Appellants note  
15 that the cited feature (positioning a species at certain locations within the doped region) is a characteristic of the “implanted species,” that “implanted species” is recited in the claims, and that the cited feature is therefore an inherent feature of the claims. Regarding the Examiner’s assertion that the limitation is met by the dopant species being present, Appellants maintain that doping does *not* provide for positioning a species at certain  
20 locations within the doped region.

#### Claim 2

Claim 2 is rejected under 35 U.S.C. §102(b) as being anticipated by Sakaguchi et al. Regarding claim 2, the Examiner asserts that the limitation “the separation plane is defined by a position and an amount of the implanted species” is a  
25 method recitation in a device claim. In the Examiner’s Answer, the Examiner asserts that Appellants’ argument that the position and amount of the implanted species is a characteristic of the separation plane and is not a method recitation is not convincing because the claim does not specifically state at what position and how much amount is the separation plane is defined. The Examiner also asserts that Sakaguchi discloses that  
30 the plane can be separated at the specific depth in the porous region by implanting ions

(col. 11, lines 1-6).

Contrary to the Examiner's assertion, regardless of whether the claims specifically state a position and amount of the implanted species, the position and amount of the implanted species is a *characteristic of the separation plane* and is *not* a method recitation. In any case, Appellants withdraw the appeal of claim 2.

Claim 6

Claim 6 is rejected under 35 U.S.C. §102(b) as being anticipated by Sakaguchi et al. Regarding claim 6, the Examiner asserts that Sakaguchi discloses that "the porous region comprises a varied porosity" (33, 34).

Appellants note that, regarding layers 33 and 34, Sakaguchi teaches that the obtained multilayer structure is then separated by any of the above-listed techniques (Step S5, FIG. 6). Since the porous layer comprises a plurality of *sub-layers 33, 43 having different respective porosities* in this embodiment, the separation of the two articles will be easier and the technique of causing a fluid jet stream to hit a lateral side (edge) of the multilayer structure will advantageously be used. (Col. 18, line 66, to col. 19, line 6; emphasis added.)

Appellants note that Sakaguchi teaches *two different layers of different porosity*. Appellants can find no disclosure or suggestion in Sakaguchi that the *porous region comprises a varied porosity*, as defined in the art and as is well understood by a person of ordinary skill in the art.

Appellants also note that the term "varied" is defined as "to change periodically or in succession." (See, dictionary.com.) Sakaguchi does not disclose or suggest that the *porous region comprises a porosity that is changed periodically or in succession*.

Thus, Sakaguchi et al. do not disclose or suggest wherein the porous region comprises a varied porosity, as required by claim 6.

Appeal Brief Arguments

Independent Claim 1

Independent claim 1 is rejected under 35 U.S.C. §102(b) as being anticipated by Sakaguchi et al. In particular, the Examiner asserts that Sakaguchi

discloses a carrier substrate (11) having a porous region (13, 33, 43) with a tuned porosity in combination with a species (doped) positioned therein defining a separation plane in the carrier substrate. The Examiner further asserts that the term “implanted” is method recitation in a device claimed and that, even though product-by-process claims are  
5 limited by and defined by the process, determination of patentability is based on the product itself. The Examiner asserts that Sakaguchi discloses the porous region is doped by diffusion, ion implantation or epitaxial growth.

Appellants note that Sakaguchi teaches a doped layer 12 (col. 3, lines 40-48, and col. 18, lines 44-52). Sakaguchi teaches that the “*porous layer 13* that operates as  
10 a separation layer shows a *uniform dopant concentration.*” (Col. 4, lines 19-22; emphasis added.) Independent claim 1 emphasizes that the carrier substrate has a porous region with a tuned porosity in combination with *an implanted species* positioned therein defining a separation plane in the carrier substrate.

First, Appellants assert that the “implanted species” limitation in claim 1 is  
15 a valid limitation for a structure claim, notwithstanding the Examiner’s position in the original Office Action. The Examiner asserts that the “implanted species” limitation is a method recitation in a device and that the patentability of a product does not depend on its method of production. Appellants submit, however, that the “implanted species” limitation in claim 1 is not a method recitation nor merely an indication of the method of  
20 production. Rather, as discussed more fully below, the “implanted species” limitation clearly defines a *characteristic* of the structure itself. As such, the “implanted species” limitation is a valid limitation for a structure claim.

Appellants further submit that the “implanted species” limitation more particularly points out and distinctly claims the invention, consistent with Section 112.  
25 The scope and meaning of the “implanted species” limitation is well defined and well understood by a person of ordinary skill in the art.

As indicated above, the “implanted species” limitation clearly defines a *characteristic* of the structure itself. The present disclosure teaches, for example, that  
30 double-implantation layer techniques may comprise the following steps. A first implantation with boron is performed, followed by a second implantation with a group IVB species, such as silicon. The second

implantation is targeted to implant a thinner region than the first implantation to create a sharp interface definition.

5       Activation of the boron implant by annealing is performed followed by anodization of the silicon to create the two regions of different porosity. An important aspect of the techniques provided herein is that to obtain various porosities, the anodization process does not have to be altered, i.e., the whole anodization process is performed at the same conditions (one anodization step). *Another benefit is that well controlled tunability of the process is accomplished by varying the amount, i.e., dose*  
10 *and the position, i.e., depth of the implanted ions, providing needed stability of this bi-layer during further decal processing, but at the same time, enabling easy separation when release process is required.* This well controlled tunability is essential to enable the structure to withstand the various processing steps required for the formation of the device,  
15 interconnect and packaging structures in the decal layer while it is still supported on the carrier substrate.

(Page 8, line 15, to page 9, line 4; emphasis added.)

This characteristic is not shown or suggested by Sakaguchi et al. As well understood by a person of ordinary skill, an implantation of a species into a carrier  
20 substrate creates a unique distribution of the species in the substrate. For example, implantation infers that the species is positioned at certain locations within the substrate (e.g., the species has a Gaussian distribution); doping does not provide for positioning a species at certain locations within the doped region. The degree of porosity (i.e., the “tuned porosity”) tracks this distribution. In other words, the porosity is tuned in  
25 accordance with the implantation profile. The implantation defines the separation plane. In other words, the separation plane in the carrier substrate is defined by having a porous region with a tuned porosity in combination with *an implanted species* positioned therein, as set forth in claim 1. Sakaguchi, alternatively, teaches a *uniform distribution with characteristics that are defined by the doping process.*

30       Thus, Appellants maintain that implantation is *not* equivalent to doping, as would be apparent to a person of ordinary skill in the art. For example, ion implantation can be performed without doping; either by ion implanting non-dopant atoms, or by implanting dopant atoms and not performing adequate thermal annealing (a process called dopant-activation). As a counter-example, doping can be performed without ion  
35 implantation (epitaxial growth, gas-phase diffusion, or solid-state diffusion, for example). Moreover, it should be noted that ion implantation may introduce more than just dopant

atoms; it may introduce lattice strain, point- and extended-crystal defects, whereas methods of doping do not. The structural differences that arise between these different methods are an indication of the non-obvious nature of the present invention. In fact, in one aspect of the present invention, the invention is doped+damaged. Sakaguchi does  
5 *not* teach the conditions necessary to make this different structure separable.

Thus, Sakaguchi et al. do not disclose or suggest a “carrier substrate having a porous region with a tuned porosity in combination with *an implanted species* positioned therein defining a separation plane in the carrier substrate,” as required by claim 1. As such, reconsideration and withdrawal of the rejections is thus respectfully  
10 requested.

Claim 2

Claim 2 is rejected under 35 U.S.C. §102(b) as being anticipated by Sakaguchi et al. Regarding claim 2, the Examiner asserts that the limitation “the separation plane is defined by a position and an amount of the implanted species” is a  
15 method recitation in a device claim.

Appellants note that the position and amount of the implanted species is a characteristic of the separation plane and is therefore *not a method recitation*. Appellants can find no disclosure or suggestion in Sakaguchi of a separation plane that is defined by a position and an amount of the implanted species.

20 Thus, Sakaguchi et al. do not disclose or suggest wherein the separation plane is defined by a position and an amount of the implanted species, as required by claim 2.

Claim 6

Claim 6 is rejected under 35 U.S.C. §102(b) as being anticipated by  
25 Sakaguchi et al. Regarding claim 6, the Examiner asserts that Sakaguchi discloses that “the porous region comprises a varied porosity” (33, 34). In the Examiner’s Answer, the Examiner asserts that Sakaguchi discloses that the porous region is made to comprise two or three thin layers having different porosities (col. 10, lines 39-60).

Appellants note that, regarding layers 33 and 34, Sakaguchi teaches that  
30 the obtained multilayer structure is then separated by any of the above-listed techniques (Step S5, FIG. 6). Since the porous layer

comprises a plurality of sub-layers 33, 43 having different respective porosities in this embodiment, the separation of the two articles will be easier and the technique of causing a fluid jet stream to hit a lateral side (edge) of the multilayer structure will advantageously be used.  
5 (Col. 18, line 66, to col. 19, line 6; emphasis added.)

Appellants note that Sakaguchi teaches *two different layers of different porosity*.

In addition, in the text cited by the Examiner, Sakaguchi teaches  
Still another porous layer having an intermediary porosity  
10 may be arranged between the first and second porous layers.  
Alternatively, a third porous layer may be formed  
adjacently relative to the second porous layer. Then, it is sufficient for the  
third porous layer to show a porosity different from that of the second  
porous layer.  
15 A multilayer structure comprising a porous layer can be  
separated with ease when the first porous layer shows a thickness smaller  
than the second porous layer.  
Since a doped layer formed by epitaxial growth shows a  
particularly uniform dopant concentration, the use of such a layer is  
20 preferable to make the process of forming a plurality of porous layers an  
easy and satisfactory one.  
(Col. 10, lines 39-60; emphasis added.)

Appellants can find no disclosure or suggestion in Sakaguchi that the *porous region*  
25 *comprises a varied porosity*, as defined in the art and as well understood by a person of  
ordinary skill in the art.

Thus, Sakaguchi et al. do not disclose or suggest wherein the porous  
region comprises a varied porosity, as required by claim 6.

#### Conclusion

30 The rejections of the cited claims under sections 102 and 103 in view of  
Sakaguchi et al. are therefore believed to be improper and should be withdrawn. The  
remaining rejected dependent claims are believed allowable for at least the reasons  
identified above with respect to the independent claims.



The attention of the Examiner and the Appeal Board to this matter is appreciated.

Respectfully,



Date: March 12, 2008

Kevin M. Mason  
Attorney for Applicant(s)  
Reg No 36,597  
Ryan, Mason & Lewis, LLP  
1300 Post Road, Suite 205  
Fairfield, CT 06824  
(203) 255-6560

APPENDIX

1. A layer transfer structure comprising a carrier substrate having a porous region with a tuned porosity in combination with an implanted-species positioned therein  
5 defining a separation plane in the carrier substrate.

2. The structure of claim 1, wherein the separation plane is defined by a position and an amount of the implanted species.

10 3. The structure of claim 1, further comprising a transfer layer on the carrier substrate.

4. The structure of claim 1, further comprising a tunable thermally regrown epitaxial layer.  
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5. The structure of claim 4, wherein a component selected from the group consisting of a device layer, an interposer structure, a functional layer and combinations comprising at least one of the foregoing components is formed in the tunable thermally regrown epitaxial layer.  
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6. The structure of claim 1, wherein the porous region comprises a varied porosity.

7. The structure of claim 1, wherein the porous region comprises at least two  
25 different porosities.

8. The structure of claim 1, wherein the implanted species are selected from the group consisting of dopants, non-dopant ions and combinations comprising at least one of the foregoing species.  
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9. The structure of claim 1, wherein the implanted species comprise silicon ions.

5

10. The structure of claim 1, wherein the carrier substrate comprises silicon.

11. The structure of claim 3, wherein the transfer layer is formed by a process selected from the group consisting of spin on coating, plasma enhanced deposition, physical vapor deposition, chemical vapor deposition, patterning methods and combinations comprising at least one of the foregoing process.

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12-48. (Withdrawn)

EVIDENCE APPENDIX

There is no evidence submitted pursuant to § 1.130, 1.131, or 1.132 or entered by the Examiner and relied upon by appellant.

RELATED PROCEEDINGS APPENDIX

There are no known decisions rendered by a court or the Board in any proceeding identified pursuant to paragraph (c)(1)(ii) of 37 CFR 41.37.